

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 214295US2RD		SERIAL NO. NEW APPLICATION	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Mutsumi FUJIHARA, et al.			
		FILING DATE HEREWITH		GROUP 2176			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
AA							
AB							
AC							
AD							
AE							
AF							
AG							
AH							
AI							
AJ							
AK							
AL							
AM							
AN							
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO	
PN	AO	JP 6-309295	11/04/94	JAPAN (w/English Abstract)		x	
PN	AP	JP 6-149634	05/31/94	JAPAN (w/English Abstract)		x	
AQ							
AR							
AS							
AT							
AU							
AV							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
PN	AW	Mutsumi FUJIHARA, et al., "SIMULATION THROUGH EXPLICIT STATE DESCRIPTION AND ITS APPLICATION TO SEMICONDUCTOR FAB OPERATION", Proceedings of the 1992 Winter Simulation Conference, 1992, pp 899-907					
	AX						
	AY						
	AZ						
Examiner <i>Paul J. Guay</i>				Date Considered 7/23/05			

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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